

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of :
Daisuke INOMATA : Mail Stop Patent Applications
Serial No. [NEW] : Atty Docket No. OKI.385D
Filed: July 31, 2003 :
For: METHOD OF FABRICATING SEMICONDUCTOR DEVICE

PRELIMINARY AMENDMENT

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, **Mail Stop Patent Applications**
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

Prior to the examination of the above-identified application, please enter
the following amendments and consider the following remarks:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which
begins on page 3 of this paper.

Remarks/Arguments begin on page 8 of this paper.